



12-10-03

1752

Attorney's Docket No. 5576-137

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Satoshi Watanabe

Serial No.: 10/052,687

Filed: January 18, 2002

For: *RESIST MATERIAL AND PATTERN FORMING METHOD*

Confirmation No.: 3765

Group Art Unit: 1752

Examiner: Thornton, Yvette C.

PATENT
RECEIVED
DEC 16 2003
TC 1700

Date: December 9, 2003

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REMARKS TO OFFICE ACTION

Sir:

These remarks are responsive to the Office Action ("Action") dated September 10, 2003 and are filed before expiration of the three month shortened statutory period. Applicants provide the present remarks to address the issues raised in the Action pursuant to the rules stated in revised 37 C.F.R. 1.121 that became effective on July 30, 2003.